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⌐	L3	438/404,409.ccls.	457
⌐	L2	438/404-412,424-426.ccls.	2956
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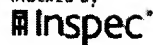 ◯ Search latest content update (29 Aug 200

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Han-Su Kim; Jenkins, K.A.; Ya-Hong Xie;
Electron Device Letters, IEEE
Volume 23, Issue 3, March 2002 Page(s):160 - 162
Digital Object Identifier 10.1109/55.988824

AbstractPlus | References | Full Text: PDF(201 KB)   IEEE JNL

☐   2. **FIPOS (Full Isolation by Porous Oxidized SIlicon) technology and Its application to LSI's**
Imai, K.; Unno, H.;
Electron Devices, IEEE Transactions on
Volume 31, Issue 3, Mar 1984 Page(s):297 - 302

AbstractPlus | Full Text: PDF(752 KB)   IEEE JNL

☐   3. **The "ISLANDS" method—A manufacturable porous silicon SOI technology**
Zorinsky, E.J.; Spratt, D.B.; Virkus, R.L.;
1986 International Electron Devices Meeting
Volume 32, 1986 Page(s):431 - 434

AbstractPlus | Full Text: PDF(688 KB)   IEEE CNF

☐   4. **Fabrication of a micro-biochemical reactor with thick thermal Isolation layer and integrated I
the micro-well**
Hoon-Sung Choi; Chang-Taeg Seo; Young-Min Kim; Jang-Kyoo Shin; Pyung Choi; Jong-Hyun Lee
Microprocesses and Nanotechnology Conference, 2003. Digest of Papers. 2003 International
29-31 Oct. 2003 Page(s):326 - 327

AbstractPlus | Full Text: PDF(256 KB)   IEEE CNF

☐   5. **An LED for silicon-based Integrated optoelectronics**
Tsybeskov, L.; Hirschman, K.D.; Duttagupta, S.P.; Fauchet, P.M.;
Device Research Conference, 1996. Digest. 54th Annual
24-26 June 1996 Page(s):150 - 151
Digital Object Identifier 10.1109/DRC.1996.546416

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